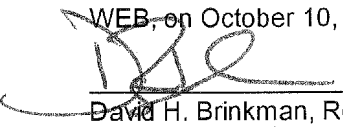


**CERTIFICATE OF ELECTRONIC  
TRANSMISSION**

I hereby certify that this correspondence for  
Application No. 10/524,525 is being electronically  
transmitted to Technology Center 1792, via EFS-  
WEB, on October 10, 2008.

  
David H. Brinkman, Reg. No. 40,532

  
Date

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s) : Martin Hausner  
Serial No. : 10/524,525  
Filed : August 18, 2005  
Confirmation No. : 1134  
Group Art Unit : 1792  
Examiner : Ahmed, Shamim  
Title : **METHOD FOR SELECTIVELY REMOVING MATERIAL  
FROM THE SURFACE OF A SUBSTRATE, MASKING  
MATERIAL FOR A WAFER, AND WAFER WITH MASKING  
MATERIAL**  
Attorney Docket No. : BEET-09

Cincinnati, Ohio 45202

October 10, 2008

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT**

In response to the Office Action mailed on April 10, 2008, please amend  
the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page  
2 of this paper.

**Remarks/Arguments** begin on page 11 of this paper.